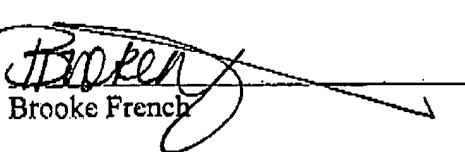


RECEIVED
CENTRAL FAX CENTER

NOV 18 2005

CERTIFICATE OF FACSIMILE TRANSMISSION
UNDER 37 CFR §1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted on the date indicated below via facsimile to the United States Patent and Trademark Office, facsimile number (571) 746-4000.

Date: November 18, 2005
Brooke FrenchIn re application of: **Chen, et al**Confirmation No.: **8561**U.S. Serial Number: **10/733,721**Art Unit: **2826**Filing Date: **December 11, 2003**Examiner: **Pert, Evan T.**Our Reference Number: **250914-1010**Title: **Method of Forming Poly-Silicon Thin Film Transistors**

Response to Restriction/Election Requirement

Total Pages Transmitted (including cover sheet) - 7

RECEIVED
CENTRAL FAX CENTER

NOV 18 2005

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Chen , et al

Confirmation No. 8561

Serial No.: 10/733,721

Group Art Unit: 2826

Filed: December 11, 2003

Examiner: Pert, Evan T.

Docket No. 250914-1010

For: **METHOD OF FORMING POLY-SILICON THIN FILM TRANSISTORS**CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR §1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted on the date indicated below via facsimile to the United States Patent and Trademark Office, Technology Group 2100, facsimile number (571) 273-8300. Total number of pages in this transmission 6.

November 18, 2005

Date

Brooke French

AMENDMENT AND RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Mail Stop – Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed on October 20, 2005, has been carefully considered. In response thereto, Applicant hereby submits the following amendments and remarks.